特許庁/Patent Office



松永 明/Akira Matsunaga

特許庁長官

Commissioner-Japan Patent Office

Education:		
B.A. Law, Tokyo University		
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山下 崇/Takashi Yamashita

特許庁 審判部長

Director-General, Trial and Appeal Department, Japan Patent Office

988年 4月 991年 4月	特許庁入庁(審査第二部応用光学) 審査第二部審査官(応用光学) ※務課工業所有接制度改正審議会	April 1988	Joined the Japan Patent Office (Applied Optics Division, the Second Examination Department)
992年 9月	総務課工業所有権制度改正審議室	April 1991	
993年10月 994年 9月	国際課 米国ワシントン大学	April 1991	Examiner, Applied Optics Division, the Second Examination Department
995年11月	国際課 課長補佐	September 1992	Industrial Property System Revision
997年 7月	外務省経済局国際機関第一課	September 1992	and Deliberation Office, General
000/5 7 8	課長補佐	O-4-b 1000	Coordination Division International Affairs Division
998年 7月 000年 6月	審査第二部光デバイス	October 1993	
	在ジュネーブ国際機関日本政府代 表部一等書記官	September 1994 November 1995	University of Washington, USA Deputy Director, International Affairs
003年10月	審判部審判官(第8部門)		Division
005年 4月	特許審査第一部応用光学	July 1997	Deputy Director, First International
006年 4月	国際課多国間政策室長		Organization Division, Economic
008年 7月	特許審査第一部光デバイス光制御		Affairs Bureau, Ministry of Foreign
	室長		Affairs of Japan
008年11月	併)国際課 PCT 制度改革検討準備室	July 1998	Optical Devices Division, the Second
	長		Examination Department
010年 7月	WIPO PCT 国際協力部長	June 2000	First Secretary, the Permanent
013年 7月	審查第一部応用光学上席審查長		Mission of Japan to the International
015年 7月	審判部審判課長		Organizations in Geneva
017年 7月 019年 7月	審查第四部長 審判部長	October 2003	Administrative Judge, the 8th Board of Trial and Appeal, Trial and Appeal
0101 .,,	H 1346X		Department Department
		April 2005	Applied Optics Division, the First
		11p111 2 000	Patent Examination Department
		April 2006	Director, Multilateral Policy Office,
		11p111 2000	International Affairs Division
		July 2008	Director, Optical Control Sub-Division
		oury 2000	Optical Devices Division, the First
			Patent Examination Department
		November 2008	Concurrently appointed as Director,
		November 2000	PCT System Reform Review and
			Preparation Office, International
			Affairs Division
		July 2010	Director, the Patent Cooperation
		July 2010	Treaty
			(PCT) International Cooperation
			Division, Innovation and Technology
			Sector, World Intellectual Property
		T 1 0010	Organization (WIPO)
		July 2013	Senior Director, Applied Optics
			Division, Patent and Design
			Examination Department (Physics,
			Optics, Social Infrastructure and Design)
		July 2015	Director, Trial and Appeal Division, Trial and Appeal Department
		July 2017	Director-General, Patent Examination
		July 2019	Department (Electronic Technology) Director-General, Trial and Appeal



和田 雄二/Yuji Wada

特許庁 首席審判長

Executive Chief Administrative Judge, Trial and Appeal Department, Japan Patent Office

1986 年	4月	特許庁入庁(審査第三部動力機械)	April 1986	Joined the Japan Patent Office (Motive
1990年	4月	特許庁審査第三部審査官(動力機械)	•	Machinery Division, the Third
1998 年	10 月	特許庁審判部審判官(第8部門)		Examination Department)
1999 年	4月	特許庁審判部審判官(第12部門)	April 1990	Examiner, Motive Machinery Division,
2004年	4月	特許庁特許審査第二部主任上席審査官	•	the Third Examination Department
		(動力機械)	October 1998	Administrative Judge, the 8th Board of
2006年	7月	特許庁審判部上級審判官(第11部門)		Trial and Appeal, Trial and Appeal
2008年	7月	特許庁特許審査第二部審査長(福祉・サ		Department
		ービス機器)	April 1999	Administrative Judge, the 12th Board of
2010年	7月	特許庁特許審査第二部審査長(搬送組	•	Trial and Appeal, Trial and Appeal
		立)		Department
2012年	4月	東京地方裁判所調査官	April 2004	Associate Managing Examiner, Motive
2015年	4月	特許庁審判部部門長(第11部門)	•	Machinery Division, the Second Patent
2017年	7月	特許庁審判部上席部門長(第11部門)		Examination Department
2019年	1月	特許庁審判部首席審判長(第19部門)	July 2006	Associate Principal Administrative
2019年	7月	特許庁審判部首席審判長(第6部門)		Judge, the 11th Board of Trial and
				Appeal, Trial and Appeal Department
			July 2008	Director, Nursing, Medical Treatment
				and Service Apparatus Division, the
				Second Patent Examination Department
			July 2010	Director, Logistics and Assembling
				Division, the Second Patent
				Examination Department
			April 2012	Judicial Research Official, Tokyo
				District Court
			April 2015	Director of the Board of Trial and
				Appeal, the 11th Board of Trial and
				Appeal, Trial and Appeal Department
			July 2017	Senior Director of the Board of Trial and
				Appeal, the 11th Board of Trial and
				Appeal, Trial and Appeal Department
			January 2019	Executive Chief Administrative Judge,
				the 19th Board of Trial and Appeal, Trial
				and Appeal Department
			July 2019	Executive Chief Administrative Judge,
				the 6th Board of Trial and Appeal, Trial
				and Appeal Department